

# The origins and limits of metal–graphene junction resistance

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**A high-quality junction between graphene and metallic contacts is crucial in the creation of high-performance graphene transistors. In an ideal metal–graphene junction, the contact resistance is determined solely by the number of conduction modes in graphene. However, as yet, measurements of contact resistance have been inconsistent, and the factors that determine the contact resistance remain unclear. Here, we report that the contact resistance in a palladium–graphene junction exhibits an anomalous temperature dependence, dropping significantly as temperature decreases to a value of just  $110 \pm 20 \Omega \mu\text{m}$  at 6 K, which is two to three times the minimum achievable resistance. Using a combination of experiment and theory we show that this behaviour results from carrier transport in graphene under the palladium contact. At low temperature, the carrier mean free path exceeds the palladium–graphene coupling length, leading to nearly ballistic transport with a transfer efficiency of  $\sim 75\%$ . As the temperature increases, this carrier transport becomes less ballistic, resulting in a considerable reduction in efficiency.**

Understanding the metal–graphene contact is of great scientific and technological importance. Carrier transport from a three-dimensional metal to a two-dimensional graphene sheet, which have very different densities of states (DOS) and work functions, is a very interesting problem. In graphene electronics, the metal–graphene contact resistance limits the on-current of graphene field-effect transistors (FETs), leading to a compromised performance for both analogue and any future digital applications<sup>1–4</sup>. In contrast, in graphene optoelectronics a strong band bending at the vicinity of the metal–graphene junction leads to efficient photocurrent generation<sup>5</sup>. Metal–graphene contact resistance has previously been measured using both four-probe and transfer length methods (TLM)<sup>6–10</sup>. In both approaches, the total resistance ( $R_{\text{total}}$ ) between the source and drain in a graphene transistor is regarded as the combination of the contact resistance ( $R_{\text{C}}$ ) and the length-dependent channel resistance. However, despite its importance, there have been few reports concentrating on understanding the intrinsic factors that control the value of the contact resistance. Reported values of  $R_{\text{C}}$  vary from a few hundred to a few thousand  $\Omega \mu\text{m}$ , and they appear to depend on the metal used, fabrication procedure, gate bias and measurement conditions. For example, a gate-dependent nickel–graphene contact resistance of  $500 \Omega \mu\text{m}$  has been reported at 300 K (ref. 7), but, more recently, and for the same system, a gate-independent and higher  $R_{\text{C}}$  has been identified<sup>10</sup>. For a titanium–graphene system, an  $R_{\text{C}}$  of  $<250 \Omega \mu\text{m}$  has been reported at liquid helium temperatures<sup>6</sup>, and in another work, an  $R_{\text{C}}$  of  $>1,000 \Omega \mu\text{m}$  at 300 K (ref. 7). It is clear that systematic experimental studies and theoretical modelling of  $R_{\text{C}}$  are highly desirable.

## Measurements of the contact resistance

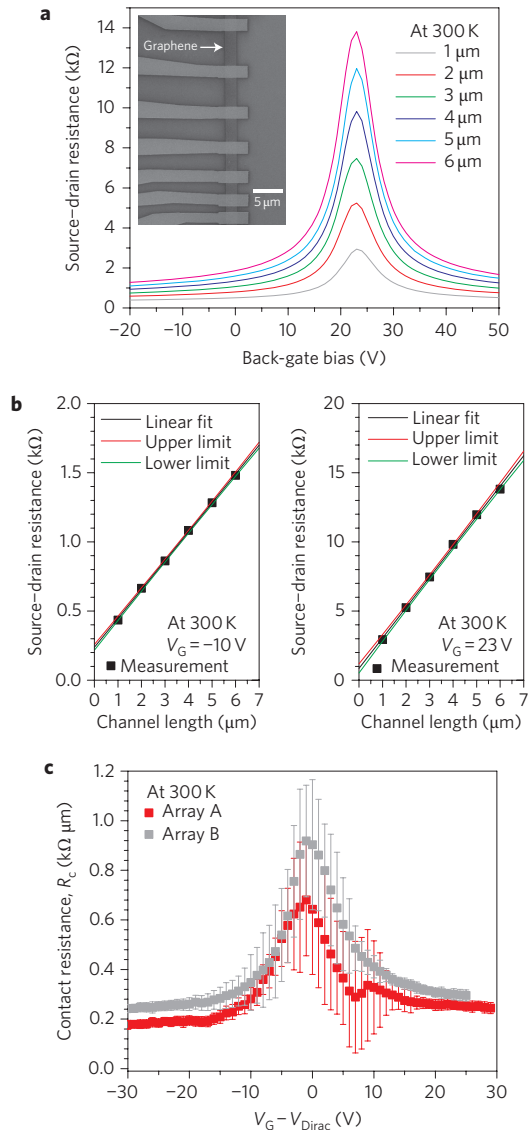
A typical example of a graphene transistor array is shown in the inset of Fig. 1a, showing six transistors designed for TLM measurements. The graphene channel width is  $2 \mu\text{m}$  and the channel length varies from  $1 \mu\text{m}$  to  $6 \mu\text{m}$ , in steps of  $1 \mu\text{m}$ . Exfoliated single-layer graphene flakes are located on 90 nm silicon oxide. The source and drain contacts are made from palladium/gold (25/25 nm). We first performed measurements at 300 K with a drain bias of 1 mV. The source–drain resistance ( $R_{\text{total}}$ ) is plotted in Fig. 1a as a function of

back-gate bias for all six graphene devices. Minimum conductance occurs at a gate bias of  $\sim 23 \text{ V}$  ( $V_{\text{Dirac}}$ , Dirac point voltage), with this value varying by less than 0.5 V across the array. TLM was used to extract the contact resistance, and two typical results are shown in Fig. 1b. TLM was used because in this case the channel length is much larger than the carrier mean free path in the channel. The channel is considered to be entirely ‘diffusive’. The black squares denote  $R_{\text{total}}$  and the black lines are linear fitting curves. The fitted contact resistance  $R_{\text{C}}$  was found to be  $230 \pm 20 \Omega$  and  $900 \pm 280 \Omega$  at back-gate biases of  $-10 \text{ V}$  and  $+23 \text{ V}$ , respectively, with 90% fitting confidence. Because the width of the graphene channel is  $2 \mu\text{m}$  and the fitted  $R_{\text{C}}$  includes contributions from both source and drain, the unit length contact resistance is also  $230 \pm 20 \Omega \mu\text{m}$  and  $900 \pm 280 \Omega \mu\text{m}$  at these two biases. The measured contact resistance is plotted as grey squares in Fig. 1c. Note that the error bars around  $V_{\text{Dirac}}$  are significantly larger than those when the channel is heavily doped. This is mainly due to the large resistance used in extrapolation around  $V_{\text{Dirac}}$ , leading to larger absolute errors in spite of the high fit quality, as shown in the right panel of Fig. 1b. Moreover, near  $V_{\text{Dirac}}$ ,  $R_{\text{total}}$  changes rapidly, and a slight variation in  $V_{\text{Dirac}}$  across the array may lead to additional errors. We measured more than 10 FET arrays and consistent results were obtained. For example, the red squares in Fig. 1c are obtained from another FET array with a similar structure. A slightly smaller contact resistance is observed in this array—when the channel is heavily p-doped ( $V_{\text{G}} = V_{\text{Dirac}} - 30 \text{ V}$ ), the contact resistance is  $185 \pm 20 \Omega \mu\text{m}$ . The contact resistance exhibits clear gate dependence; it peaks around  $V_{\text{Dirac}}$  and decreases as the channel is field-doped by the back gate. Moreover, the p and n branches always show a moderate asymmetry: contact resistance in the n branch is always larger than that in the p branch.

We also measured the temperature dependence of the contact resistance. The transfer characteristics of a graphene FET with  $2\text{-}\mu\text{m}$ -wide by  $1\text{-}\mu\text{m}$ -long channel (from array A in Fig. 1c) are plotted in Fig. 2a at temperatures ranging from 6 to 300 K. The source–drain current increases monotonically as the temperature decreases. This is partially due to the enhancement of the carrier mobility at low temperature, as shown in the inset of Fig. 2a. More importantly, the contact resistance

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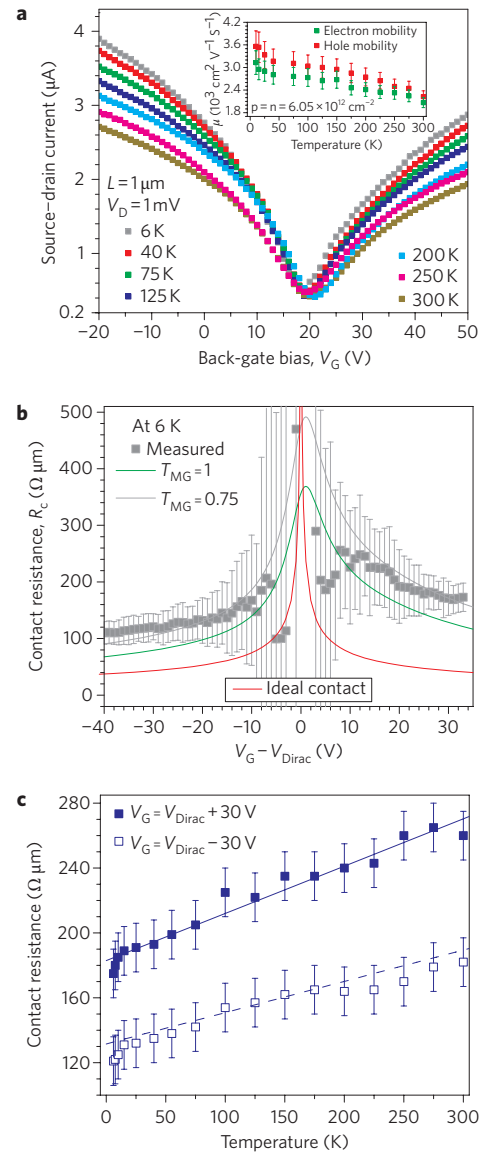


**Figure 1 | Determination of palladium-graphene contact resistance using the transfer length method (TLM).** **a**, Total resistance ( $R_{\text{total}}$ ) between source and drain in a graphene FET array as a function of back-gate bias. Inset: scanning electron micrograph of a graphene FET array consisting of six devices with channel lengths varying from 1 to 6  $\mu\text{m}$ , in steps of 1  $\mu\text{m}$ . **b**, Deriving contact resistance using the TLM at gate biases of  $-10\text{ V}$  (p-doped) and  $23\text{ V}$  (Dirac point voltage), respectively. Black squares, measured total resistance; black line, linear fitting curve. Red and green lines, upper and lower 90% confidence limits, respectively, from which the error bars are inferred. **c**, Contact resistance as a function of gate bias. Red and grey squares, measured contact resistance from FET arrays A and B, respectively.

is reduced significantly at low temperatures. The gate dependence of the contact resistance at 6 K is plotted in Fig. 2b, and a minimum contact resistance of  $110 \pm 20\ \Omega\ \mu\text{m}$  is realized at  $V_G = V_{\text{Dirac}} - 40\text{ V}$ . Figure 2c shows the temperature dependence of the contact resistance. At  $V_G = V_{\text{Dirac}} - 30\text{ V}$  (heavily p-doped channel), the contact resistance decreases from  $185 \pm 20\ \Omega\ \mu\text{m}$  at 300 K to  $120 \pm 20\ \Omega\ \mu\text{m}$  at 6 K. At  $V_G = V_{\text{Dirac}} + 30\text{ V}$  (heavily n-doped channel), a similar trend is observed.

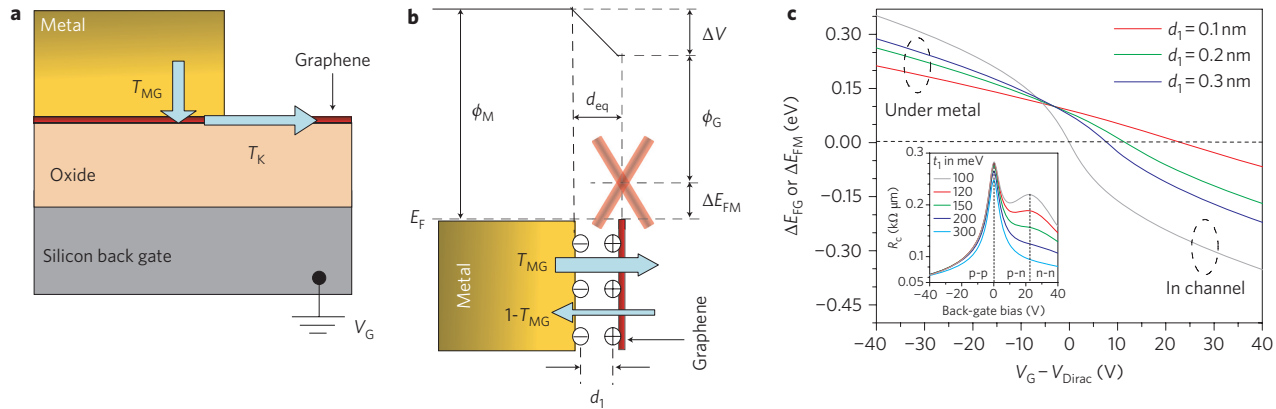
#### Contact resistance calculation by Landauer's approach

The contact conductance of the graphene-metal junction,  $G$ , can be understood using Landauer's approach<sup>11</sup>,  $G = (4e^2/h)TM$ , where  $M$



**Figure 2 | Temperature dependence of contact resistance.** **a**, Transfer characteristics of a graphene FET with a 2- $\mu\text{m}$ -wide and 1- $\mu\text{m}$ -long graphene channel at temperatures ranging from 6 to 300 K. Inset: measured electron and hole mobilities as a function of temperature at a carrier density of  $\sim 6 \times 10^{12}\text{ cm}^{-2}$ . **b**, Grey squares, measured palladium-graphene contact resistance at 6 K as a function of gate bias. Grey and green solid lines denote the calculated contact resistance, assuming  $T_{\text{MG}} = 0.75$  and 1, respectively. Values used in the calculation:  $\eta = 5\text{ meV}$ ,  $t_1 = 300\text{ meV}$ ,  $d_1 = 1\ \text{\AA}$ . Red line, contact resistance in an ideal metal-graphene contact on 90 nm oxide. **c**, Measured palladium-graphene contact resistance as a function of temperature at gate biases of  $V_{\text{Dirac}} - 30\text{ V}$  and  $V_{\text{Dirac}} + 30\text{ V}$ .

is the number of conduction modes in graphene,  $T$  is the carrier transmission probability,  $e$  is the electron charge, and  $h$  is Planck's constant. For a graphene channel of width  $W$ , the number of quantum modes is  $M = (\Delta E_F / \pi \hbar V_F)W$  (ref. 11), where  $\Delta E_F$  is the difference between the Fermi level and Dirac point energies, and  $V_F$  ( $\sim 1 \times 10^8\text{ cm s}^{-1}$ ) is the Fermi velocity. However, in a real graphene-metal junction, determination of the contact resistance is much more involved. Carrier transport at the junction consists of two cascaded processes: initial injection from the metal to the graphene underneath it, then transport to the gate-controlled channel, with probabilities  $T_{\text{MG}}$  and  $T_K$ , respectively, as shown in Fig. 3a.  $T_{\text{MG}}$  reflects the coupling strength



**Figure 3 | Carrier transport processes at the palladium-graphene junction and gate dependence of Dirac-point energies in graphene under palladium and in the channel.** **a**, Schematic view of two cascaded carrier transport processes at the metal-graphene junction, with transmission efficiencies  $T_{MG}$  and  $T_K$ , respectively. **b**, Schematic view of the band profile and dipole formation at the metal-graphene interface.  $\phi_M$  is the palladium work function,  $\phi_G$  represents the work function of monolayer graphene,  $\Delta E_{FM}$  ( $\Delta E_{FG}$ ) is the difference between the Dirac-point and Fermi-level energies in the metal-doped graphene (graphene channel),  $\Delta V$  is the total built-in potential difference,  $d_{eq}$  is the equilibrium distance, and  $d_1$  is the effective distance between the charge sheets in the graphene and metal. The red cross represents the Dirac cone, and thick red lines are used to denote the broadening of electronic states. **c**, Calculated  $\Delta E_{FG}$  (grey line) and  $\Delta E_{FM}$  (red, green, and blue lines for different  $d_1$ ) as a function of gate bias. Inset: calculated contact resistance  $R_C$  as a function of gate bias for different broadening energy  $t_1$  from 100 to 300 meV with  $d_1 = 1 \text{ \AA}$  and perfect  $T_{MG}$  and  $T_K$ .

between the metal and the graphene under it<sup>12-14</sup>. Moreover, the graphene under the metal has a limited number of conduction modes. Contact conductance is therefore determined by  $T_{MG}$ ,  $T_K$  and the lowest number of modes under the metal ( $M_m$ ) or in the gate-controlled graphene channel ( $M_{ch}$ ); that is,  $M = \min\{M_m, M_{ch}\}$ . The graphene under the metal is doped by charge transfer<sup>15-17</sup>, and its electronic states acquire a finite width due to the coupling to the metal  $d$  states<sup>18</sup>. In the graphene channel, the V-shaped transfer characteristic is also broadened due to electron-hole puddle formation<sup>19</sup>. In addition, although p-p' and n-n' interfacial potential barriers are nearly transparent due to Klein tunnelling<sup>20,21</sup>, the transmission probability  $T_K$  through p-n junctions of finite width can be smaller than unity and also depend on the gate due to the reflection that occurs at carrier incident angles other than normal<sup>20-26</sup>, thus contributing to the contact resistance. Such gate dependence was previously predicted theoretically by Cayssol and colleagues<sup>24</sup> and Sonin<sup>25</sup>. Therefore, a model describing the origin of the contact resistance should include (i) the gate dependence of the Dirac point energy and the broadening of the density of states in the graphene under the metal and in the channel, (ii) the carrier tunnelling probability  $T_{MG}$  through the metal-graphene interface, and (iii) the carrier tunnelling probability  $T_K$  as a function of the interfacial potential barrier width, shape and height.

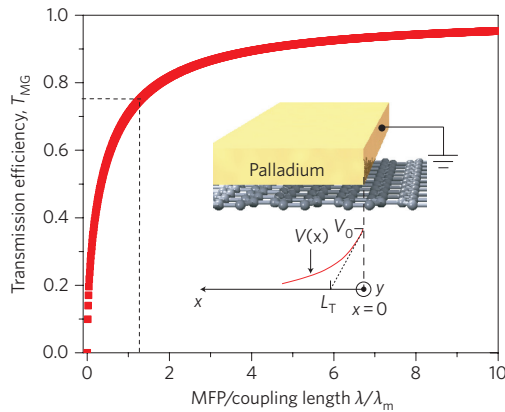
The gate dependences of the Fermi level relative to the Dirac point energy in the graphene channel ( $\Delta E_{FG}$ ) and in the graphene under the metal ( $\Delta E_{FM}$ ) are shown in Fig. 3c. In calculating  $\Delta E_{FM}$ , three different effective electrostatic distances between the metal and graphene underneath ( $d_1 = 1, 2$  and  $3 \text{ \AA}$ ) are considered. Details of the calculation are presented in the Methods. We also assume that transport through the interfacial potential p-n junctions is ballistic<sup>23</sup>; that is, the mean free path is larger than the width of the p-n junction. The unit length contact conductance is evaluated using the following modified Landauer formula, taking  $T_{MG}$ ,  $T_K$  and broadening of the electronic states into account:

$$\frac{1}{R_C} = \frac{4e^2}{h} \int_{-E_0}^{E_0} dE_1 \text{Voigt}(E_1 - \Delta E_{FM}, t_1, \eta) \int_{-\infty}^{\infty} dE_2 G(E_2 - \Delta E_{FG}, t_2) \frac{1}{W} \sum_{n=0}^{\min\{M_1, M_2\}} T(k_y = n \frac{\pi}{W}, E_1, E_2) \quad (1)$$

where  $T = T_K T_{MG} / (1 - (1 - T_K)(1 - T_{MG}))$  (ref. 11),  $W$  is the width of the channel,  $M_{1,2} = W|E_{1,2}| / (\pi \hbar v_F)$ , and  $k_y$  is the perpendicular wave vector. Here  $\Delta E_{FM}$  and  $\Delta E_{FG}$  determine the number of conduction modes in the graphene underneath the metal and in the channel, respectively. We use Gaussian broadening  $G(x, t_2) = \exp(-x^2/t_2^2) / (t_2 \pi^{1/2})$  to model the random disorder potential in the channel with  $t_2 = \hbar v_F \sqrt{2\pi n_0} = 117 \text{ meV}$ , corresponding to an experimental  $n_0$  (minimum sheet carrier concentration) of  $5 \times 10^{11} \text{ cm}^{-2}$ . In addition to the inhomogeneous broadening, graphene states under the metal have a homogeneous (lifetime) broadening  $\eta$  due to the coupling to the metal. We therefore model the total broadening by a Voigt function  $\text{Voigt}(x, t_1, \eta)$ , which is a convolution of a Gaussian of width  $t_1$  and a Lorentzian of width  $\eta$ , and a cutoff energy  $E_0$  of 1 eV, which is the typical bandwidth of  $d$ -bands in transition metals. The random potential disorder is expected to be much larger under the polycrystalline metal than in the channel. For a variation of the metal-graphene distance of  $2 \text{ \AA}$  (from  $3 \text{ \AA}$  to  $5 \text{ \AA}$ ), a 0.9 eV change in potential has been calculated<sup>15</sup>. The lifetime broadening  $\eta$  according to Fermi's golden rule, is given by

$$\eta(E_v) = 2\pi |\tilde{M}|^2 N(E_v) \quad (2)$$

where  $N$  is the density of metallic states,  $E_v$  is the energy of the graphene under the metal, and  $\tilde{M}$  represents the average coupling strength between the metal  $d$ -orbitals and graphene states<sup>13</sup>. For an ideal planar geometry of graphene and palladium metal,  $\eta$  was estimated to be 60 meV (ref. 13). However, the spatially averaged effective  $\eta$  can be substantially smaller due to variations in the graphene-metal distance and, therefore, of the coupling strength  $\tilde{M}$ . Assuming  $T_K = T_{MG} = 1$  and  $\eta = 5 \text{ meV}$  (see Methods), in the inset of Fig. 3c we show the calculated contact resistance for  $t_1$  from 100 meV to 300 meV. The contact resistance exhibits two peaks when the broadening energy  $t_1$  is 100 meV: one corresponding to the minimum DOS in the channel ( $\Delta E_{FG} = 0$ ) and the other to the minimum DOS in the graphene under the metal ( $\Delta E_{FM} = 0$ ). Experimentally, we have not observed the latter peak, indicating a large  $t_1$  ( $>200 \text{ meV}$ ) in graphene under palladium. In the calculations presented below, a  $t_1$  of 300 meV is used, which corresponds to the total energy variation of 0.9 eV calculated in ref. 15.



**Figure 4 | Transmission efficiency  $T_{MG}$ , determined using Matthiessen's rule.** Calculated transmission efficiency from metal to metal-doped graphene,  $T_{MG}$ , as a function of the ratio of the mean free path ( $\lambda$ ) and metal-graphene coupling length ( $\lambda_m$ ). Inset: palladium-graphene contact, showing transfer length  $L_T$ .

The dependence of  $T_K$  on the interfacial potential profile between the metal-doped graphene and the graphene channel (Supplementary Fig. S1, inset) is presented in Supplementary Section I. The calculated contact resistances, based on equation (1) and using an exponential potential profile with a characteristic barrier width  $W_B$  of 20 nm, are shown in Fig. 2b for  $T_{MG}$  values of 100% and 75%, respectively. The measured contact resistance at 6 K agrees well with the calculated value for a  $T_{MG}$  of 75%, indicating a high-quality metal-graphene junction. At  $V_G = V_{Dirac} - 40$  V, the calculated contact resistance assuming  $T_{MG} = 100\%$  is  $\sim 65 \Omega \mu\text{m}$ , slightly larger than that in an ideal metal-graphene junction, which is  $\sim 40 \Omega \mu\text{m}$ , as estimated using Landauer's formula  $G = (4e^2/h)TM$  with  $T = 1$ . The difference is primarily due to the limited number of conduction modes in the graphene underneath the metal, which is restricted by the metal-induced doping and broadening. In an ideal metal-graphene junction, on the other hand, the number of conduction modes is solely determined by the gate bias.

### Carrier transport at the metal-graphene junction

In our experiments, we consistently observed an  $\sim 50\%$  increase in contact resistance in both the p and n branches as the temperature increased from 6 K to 300 K, as shown in Fig. 2c. In contrast, in conventional metal-semiconductor junctions, the contact resistance usually decreases as the temperature increases, because of the reduction in the effective Schottky barrier height and enhancement in thermionic carrier emission. We use a simple physical model to understand these results. First, we assume that on reversing the biasing conditions, transport from metal to graphene or graphene to metal is equivalent. For our discussion it is conceptually simpler to consider graphene-to-metal carrier injection. As shown in the inset of Fig. 4, a bias  $V_0$  is applied to the graphene channel, and the metal itself is grounded. Carriers in the graphene under the metal electrode can move ballistically or diffusively. In the ballistic limit, the only scattering process (transfer process) is that induced by coupling to the metal, which can be described by an effective coupling length  $\lambda_m (= \hbar V_F / \pi \eta)$ . In the diffusive transport limit, we introduce a scattering mean free path  $\lambda$  within the contacted graphene segment. Here, this mean free path is defined as  $\lambda = \pi V_F \tau / 2$ , where  $\tau$  is the scattering time (see Method for details regarding  $\lambda_m$  and  $\lambda$ ). Now there are two options for the carrier, propagating within the graphene plane or being transferred (irreversibly) to the metal. When  $\lambda \gg \lambda_m$  and the contact length is sufficiently long ( $2 \mu\text{m}$  in our samples), transfer to the metal is

complete, and the contact acts ideally. In the diffusive limit where  $\lambda \ll \lambda_m$ , on the other hand, we would expect a much reduced transmission probability.

To formalize the above physical picture, we note that the carrier injection rate over a length segment  $dx$  can be calculated from<sup>27</sup>

$$dI = \frac{e^2}{\hbar} \eta D_E V(x) W dx \quad (3)$$

where  $\eta$  is again the metal-graphene coupling strength from equation (2),  $D_E = 2\Delta E_F / (\pi \hbar^2 V_F^2)$  is the graphene DOS per unit area,  $V(x)$  is the local electrostatic potential in graphene under the grounded metal, and  $W$  is the width of the graphene. In the diffusive transport regime we introduce a second current-voltage relation  $I = \sigma dV(x)/dx$ , where the Boltzmann conductivity  $\sigma$  is given by  $\sigma = e^2 V_F^2 D_E \tau / 2$ . Solution of these two coupled equations gives a simple form for the potential:  $V(x) = V_0 \exp(-x/L_T)$ , where  $V_0$  is the potential at  $x = 0$  (Fig. 4, inset) and the effective transfer length of the carriers from the metal to graphene is given by  $L_T = \sqrt{\lambda \lambda_m}$ . Here, we must stress that the transfer length in the metal-graphene contact is very different from that in a conventional metal-semiconductor contact. Extraction of  $L_T$  in the TLM plot<sup>28</sup>, as shown in Fig. 1b, does not usually lead to satisfactory results. This issue is discussed in detail in Supplementary Section II.

The injection efficiency  $T_{MG}$  is  $\sqrt{\lambda/\lambda_m}$  in the diffusive transport limit (see Methods for details). Considering transport in the graphene plane and transfer to the metal electrode as two independent transport channels and applying Matthiessen's rule, we can write the effective metal-to-graphene carrier injection probability as  $T_{MG} = \sqrt{\lambda/(\lambda_m + \lambda)}$ . In the ballistic transport limit, on the other hand,  $\lambda \gg \lambda_m$ , and the transmission probability  $T_{MG}$  should be very close to one<sup>13,14</sup> and nearly independent of the metal-graphene coupling  $\eta$ , as long as the contact length is large. The carrier tunnelling probability  $T_{MG} = \sqrt{\lambda/(\lambda_m + \lambda)}$  is plotted in Fig. 4. We see that at 6 K, the deduced injection efficiency of 75% for the palladium-graphene contact implies a mean free path exceeding the coupling length, confirming the nearly ballistic nature of the contact. As temperature increases, the contact becomes less ballistic and  $T_{MG}$  decreases considerably.

We attribute the observed temperature dependence of the contact resistance to changes in the scattering mean free path  $\lambda$  and the metal graphene coupling length  $\lambda_m$ . Changes in  $\lambda_m$  can be the result of the anharmonic nature of the carbon-metal atom vibrational potential. As the temperature increases, the anharmonicity leads to an expansion of the graphene-metal distance, which, in turn, reduces the carbon  $\pi$  state and metal  $d$  state interaction, leading to a larger  $\lambda_m$ . On the other hand, a temperature increase usually leads to a reduction in  $\lambda$  in single-layer graphene. Both effects are expected to reduce  $T_{MG}$  and increase the contact resistance. From mobility measurements in the channel, as shown in the inset of Fig. 2a, we observe a roughly linear temperature dependence of the mean free path. Linear temperature dependence typically implies mobility limited by phonon scattering. We should emphasize that the scattering is expected to be modified for the graphene under the metal, because phonons can become harder (through charge transfer), and the deformation potential can be modified due to interaction with the metal. In addition, we speculate that an anharmonic potential between the metal and graphene can also modify the graphene-metal coupling (that is, thermal expansion), which is also expected to depend linearly on temperature. Both effects would then lead to an approximately linear temperature dependence of  $T_{MG}$ , as observed in our data. These factors may also determine the previously reported metallic temperature dependence of the carbon nanotube-platinum contacts<sup>29</sup>. Evaluation of the relative contributions of these two effects will be the subject of future work.

### Towards an ideal metal-graphene junction

In Fig. 2b, we also plot the contact resistance in an idealized metal-graphene contact on a 90 nm oxide based on  $G = (4e^2/h)TM$  ( $T = 1$ ), as discussed previously. Compared with the ideal metal-graphene contact, the experimental results are approximately two to three times larger and exhibit strong asymmetry in the p and n branches. To approach such an ideal contact even at room temperature, the following methods can be adopted. (i) The quality of graphene can be improved. Choosing graphene with higher mobility can lead to a larger mean free path and therefore better carrier injection efficiency from metal to graphene, even at room temperature. (ii) Other metallization schemes can be used (for example, atomic layer deposition of the metallic materials) to improve the morphology of the metal, which may lead to a smaller metal-graphene coupling length. (iii) Other metals can be chosen, which can lead to a higher metal-induced doping concentration in the graphene under the metal. (iv) The graphene under the metal can be intentionally doped so that the number of conduction modes in the graphene under the metal is always larger than that in the channel, regardless of the gate bias. (v) The gate oxide thickness can be reduced to minimize the interfacial potential width, therefore reducing the asymmetry in the p and n branches.

In summary, we have investigated the palladium-graphene contact resistance, both experimentally and theoretically. A contact resistance as small as  $110 \pm 20 \Omega \mu\text{m}$  was realized. Moreover, analysis of the combination of experimental and theoretical results showed that carrier transport in graphene under palladium is nearly ballistic ( $\lambda > \lambda_m$ ) and the transmission efficiency is  $\sim 75\%$  at 6 K. At room temperature, diffusive transport in the graphene under the metal has to be taken into account to understand the observed significant increase in contact resistance. The realization of low metal-graphene contact resistance and the revelation of its intrinsic limiting factors would have important ramifications for the development and use of high-performance graphene devices.

### Methods

**Evaluation of the difference in Dirac-point and Fermi-level energies.** The difference in Dirac point and Fermi-level energies in the graphene channel,  $\Delta E_{FG}$ , was estimated using the gate-induced charge density and the graphene DOS Gaussian broadened with width  $t_2$ . The gate capacitance  $C_G = \epsilon_0 \epsilon_r A/d_{ox}$  was used to calculate the charge density, where  $\epsilon_0$  is vacuum permittivity,  $\epsilon_r$  is 3.9,  $A$  is the area of the graphene, and  $d_{ox}$  is 90 nm. To obtain the Dirac-point energy under the metal, we extended the model introduced by Giovannetti and colleagues<sup>15</sup>, which is shown schematically in Fig. 3b, to the finite gate bias case. The charge on the graphene under the metal,  $\rho_{GM}$ , and its electrostatic potential  $\Delta_{tr}$  were determined from the equation

$$\begin{aligned} \rho_{GM} &= -C_G(V_G - V_{Dirac}) + (C_G + C_M) \frac{\Delta_{tr}}{e} \\ &= e\Delta E_{FM} |\Delta E_{FM}| / (\pi \hbar^2 V_G^2) \end{aligned}$$

where the capacitive couplings to the metal and the back gate are given by  $C_M$  and  $C_G$ , respectively, and  $\Delta E_{FM} = W_M - W_G - \Delta_{tr} - \Delta_c$ . Here,  $C_M = \epsilon_0 A/d_1$ . The value of  $d_1$  can differ from the equilibrium distance  $d_{eq}$  ( $\sim 3 \text{ \AA}$ ) due to the spatial extension of the carbon  $p_z$  and metal  $d$  orbitals. The pure palladium ( $W_M$ ) and graphene ( $W_G$ ) work functions were 5.6 eV and 4.5 eV, respectively<sup>15</sup>.  $\Delta_c$  was used to account for the interaction of the graphene and metal orbitals<sup>15,16</sup> and was estimated to be  $\sim 0.9$  eV. The difference between Fermi-level and Dirac-point energies in the graphene under the metal,  $\Delta E_{FM}$ , is shown in Fig. 3c for  $d_1 = 1, 2$  and  $3 \text{ \AA}$ .  $\Delta E_{FM}$  and  $\Delta E_{FG}$  cross at  $V_G - V_{Dirac} \approx -6$  V, which is consistent with the flipping of photocurrent polarity at  $V_G - V_{Dirac} = 15\text{--}20$  V in graphene FETs on 300 nm SiO<sub>2</sub> (ref. 11). In the contact resistance calculations presented here, a  $d_1$  of  $1 \text{ \AA}$  was used<sup>15</sup>. The relationship between  $d_1$  and  $\Delta$  has been discussed in the literature and, as expected, the results based on density function theory in ref. 15 fit well a roughly exponential dependence of  $\Delta$  on  $d_1$ . Given the many factors at play, we based our model on the parameters extracted from our previous experimental photocurrent imaging experiments, which are also consistent with the theoretical results of ref. 15. For different metals, both  $d_1$  and  $\Delta_c$  can differ greatly due to the different metal-graphene bonding and different metal work functions. Theoretical investigations for many metals are discussed in detail in ref. 15. In Supplementary Section III, we discuss our new experimental results for a titanium-graphene contact. The experimentally observed larger titanium-graphene contact resistance may be due to

the small titanium work function (which is close to that of graphene) and possible metal oxidation.

**Modelling the current-voltage distribution in graphene under metal.** At the diffusive limit, equation (3) and  $I = \sigma dV(x)/dx$  (where  $\sigma$  is Boltzmann conductivity) can be rearranged to give

$$\frac{dI}{dx} = C \frac{V(x)}{\lambda_m}, \quad I = -C\lambda \frac{dV(x)}{dx}$$

where  $C = W(4e^2/h)(k_F/\pi)$ ,  $\lambda = \pi V_F \tau/2$ ,  $\lambda_m = (\hbar V_F/\pi \eta)$ , and  $k_F$  is the Fermi wave vector. All other parameters have already been defined in the main text. The solution for the electrostatic potential in the graphene under the metal has the simple form  $V(x) = V_0 \exp(-x/L_T)$ , where  $V_0$  is the potential at  $x = 0$ , and  $L_T = \sqrt{\lambda \lambda_m}$  is the transfer length (Fig. 4, inset). The total injected current is given by  $I_{x=0} = V_0 C L_T / \lambda_m = V_0 C \sqrt{\lambda/\lambda_m}$ , although for an ideal ballistic contact  $I = CV_0$ . Therefore,  $T_{MG} = L_T/\lambda_m = \sqrt{\lambda/\lambda_m}$  is determined by competition between carrier scattering in the graphene under the metal and the graphene-metal coupling at the diffusive limit. Note that, in the ballistic limit, the second equation becomes  $I = -CV$ , which results in a transfer length  $L_T = \lambda_m$ . Note that recent contact resistance measurements in carbon nanotube transistors have suggested an effective transfer length of 40–100 nm (ref. 30), which corresponds to  $\eta = 2\text{--}5$  meV.

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### Author contributions

All authors discussed the results and commented on the manuscript.

### Additional information

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